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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Samit Kumar Basu et al.

Serial No.: 10/699,087

Filed: October 31, 2003

For: METHOD AND APPARATUS  
FOR CALIBRATING  
VOLUMETRIC COMPUTED  
TOMOGRAPHY SYSTEMS

§ Group Art Unit: 2882

§ Examiner: Chih-Cheng Glen Kao

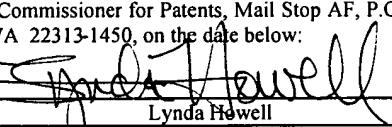
§ Atty. Docket: 131029-1/YOD  
GERD:0228

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P.O. Box 1450  
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Date

  
Lynda Howell

**SUPPLEMENTAL AMENDMENT AND RESPONSE TO  
FINAL OFFICE ACTION MAILED ON AUGUST 2, 2005**

Dear Sir:

This is in Supplemental Response to the Final Office Action mailed on August 2, 2005.